

MAY 11 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Application of: SINGH et al.

Appln No.: 10/082,010

Examiner: Umez Eronim, Lynette T.

Date Filed: February 22, 2002

Group: 1765

For: SLURRY AND METHOD FOR CHEMICAL MECHANICAL POLISHING
OF METAL STRUCTURES INCLUDING REFRACTORY METAL
BASED BARRIER LAYERS

CERTIFICATE UNDER 37 CFR 1.8(a)
I hereby certify that this correspondence addressed to Mail Stop
Amendment, Commissioner for Patents is being transmitted via
facsimile No 577-273-8300 on May 11, 2006

Neil R. Jetter Reg. No 40,803

REPLY TO OFFICE ACTION

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

This Reply is responsive to the Office Action mailed January 11, 2006.

Amendments to the Claims are contained in the complete claim listing which appears on
pages 2-7 of this document.

Remarks/arguments begin on page 8 of this document.